



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit: 2892
Examiner: Mr. William F. Kraig

In re PATENT APPLICATION of:

Applicant :	Akira TAKAHASHI)
)
Serial No. :	10/798,482)
)
Filed :	March 12, 2004)
)
For :	DRY ETCHING METHOD FOR SEMICONDUCTOR DEVICE)
)
Attorney Ref. :	OKI 414)
)

January 12, 2011

Mail Stop Amendment

Director of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Supplemental to the Amendment filed on September 21, 2010, please further amend the above-identified application as specified on the following pages.